



AP/2877

501.30598CC3

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): MORIOKA, et al  
Serial No.: 09/805,188  
Filed: March 14, 2001  
For: METHOD AND APPARATUS FOR ANALYZING THE STATE  
OF GENERATION OF FOREIGN PARTICLES IN  
SEMICONDUCTOR FABRICATION PROCESS  
Group: 2877  
Examiner: T. Nguyen

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PETITION FOR EXTENSION OF TIME

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

January 23, 2004

Sir:

In the matter of the above-identified application, applicant(s) hereby respectfully petition for an extension of time to permit filing of a response within the first month subsequent to the shortened statutory period set in the outstanding Office Action mailed September 23, 2003. A payment in the amount of \$110.00 to cover the required fee for the requested extension of time is attached hereto.

It is respectfully requested that any shortage in the fee be charged to the account of Antonelli, Terry, Stout & Kraus, LLP, Account No. 01-2135 (501.30598CC3).

Respectfully submitted,

Melvin Kraus  
Registration No. 22,466  
ANTONELLI, TERRY, STOUT & KRAUS, LLP

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(703) 312-6600